

PRACTICAL SESSIONS Dimensional Metrology

MECHANICAL & MATERIALS ENGINEERING FOR PARTICLE ACCELERATORS AND DETECTORS

Introduction

Welcome to this hands-on session dedicated to Dimensional Metrology!

Helpers for the sessions:

Optical Profilometry: Giacomo Calchi **Role:** Dimensional Metrology Engineer giacomo.calchi@cern.ch

Thomas Carlier - BRUKER Role: Application Scientist thomas.carlier@bruker.com Sergey Lemeshko - BRUKER **Role:** Senior Sales Engineer sergey.lemeshko@bruker.com

3D Laser Scanning:

Role: Dimensional Metrology Engineer maciej.burkowski@cern.ch

Olivier Langlois - AMETEK Role: Application Engineer Olivier.fr.langlois@ametek.com

CERN Metrology Laboratory Website: Here

Maciej Burkowski



Objective & Contents

...in connection with the lectures

"Introduction to Design for Accelerators" – M. Timmins "Introduction to Metrology" – P. Shore "Measurement Uncertainty" - S. Piano

Objectives:

- Review of basic ISO GPS principles (roughness, geometrical tolerances)
- Knowledge of the working principles of the two technologies;
- Knowledge and practical application of the basic workflows of the two technologies in dimensional metrology applications;
- Awareness of the further capabilities and potential applications of the two technologies.

Contents:

2 sessions will be held covering the two techniques:

- Optical profilometry
- 3D scanning



Introduction

21 / 22 students

10 / 11 students – Optical profilometry

- **Topic:** Roughness measurement using optical profilometry
- **Duration:** 1h30 minutes
- **Helpers**: Giacomo, Thomas, Sergey

10 / 11 students – 3D Scanning

- **Topic:** <u>3D scanning of a vacuum chamber</u> using a handheld laser scanner
- **Duration:** 1h30 minutes
- **Helpers**: Maciej, Olivier



Link to slideshows



https://indico.cern.ch/event/1326947/timetable/



